

Lecture 14: Wires

Outline

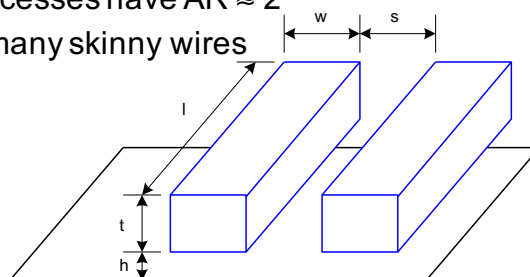
- ☐ Introduction
- ☐ Interconnect Modeling
 - Wire Resistance
 - Wire Capacitance
- ☐ Wire RC Delay
- ☐ Crosstalk
- ☐ Wire Engineering
- ☐ Repeaters

Introduction

- ❑ Chips are mostly made of wires called *interconnect*
 - In stick diagram, wires set size
 - Transistors are little things under the wires
 - Many layers of wires
- ❑ Wires are as important as transistors
 - Speed
 - Power
 - Noise
- ❑ Alternating layers run orthogonally

Wire Geometry

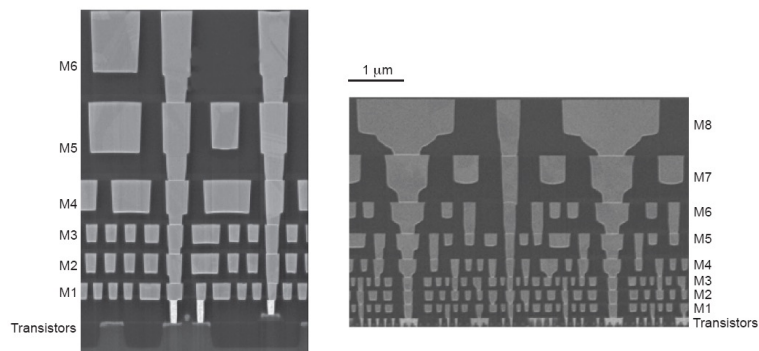
- ❑ Pitch = $w + s$
- ❑ Aspect ratio: $AR = t/w$
 - Old processes had $AR \ll 1$
 - Modern processes have $AR \approx 2$
 - Pack in many skinny wires



Layer Stack

- ❑ AMI 0.6 μm process has 3 metal layers
 - M1 for within-cell routing
 - M2 for vertical routing between cells
 - M3 for horizontal routing between cells
- ❑ Modern processes use 6-10+ metal layers
 - M1: thin, narrow ($< 3\lambda$)
 - High density cells
 - Mid layers
 - Thicker and wider, (density vs. speed)
 - Top layers: thickest
 - For V_{DD} , GND, clk

Example



Intel 90 nm Stack

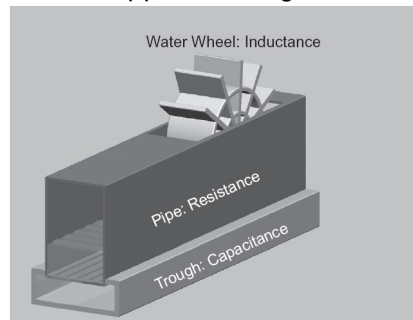
[Thompson02]

Intel 45 nm Stack

[Moon08]

Interconnect Modeling

- ❑ Current in a wire is analogous to current in a pipe
 - Resistance: narrow size impedes flow
 - Capacitance: trough under the leaky pipe must fill first
 - Inductance: paddle wheel inertia opposes changes in flow rate
 - Negligible for most wires



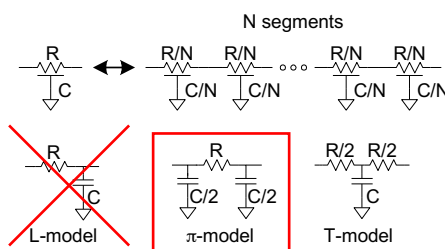
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Lumped Element Models

- ❑ Wires are a distributed system
 - Approximate with lumped element models



- ❑ 3-segment π -model is accurate to 3% in simulation
- ❑ L-model needs 100 segments for same accuracy!
- ❑ Use single segment π -model for Elmore delay

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Wire Resistance

□ $\rho = \text{resistivity } (\Omega \cdot \text{m})$

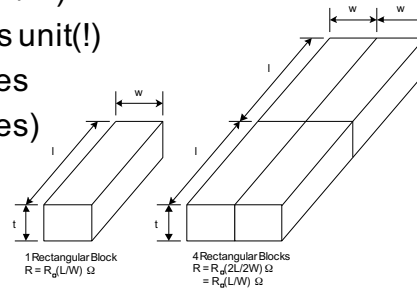
$R =$

□ $R_{\square} = \text{sheet resistance } (\Omega/\square)$

– \square is a dimensionless unit(!)

□ Count number of squares

– $R = R_{\square} * (\text{\# of squares})$



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Choice of Metals

□ Until 180 nm generation, most wires were aluminum

□ Contemporary processes normally use copper

– Cu atoms diffuse into silicon and damage FETs

– Must be surrounded by a diffusion barrier

Metal	Bulk resistivity ($\mu\Omega \cdot \text{cm}$)
Silver (Ag)	1.6
Copper (Cu)	1.7
Gold (Au)	2.2
Aluminum (Al)	2.8
Tungsten (W)	5.3
Titanium (Ti)	43.0

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Contacts Resistance

- ❑ Contacts and vias also have 2-20 Ω
- ❑ Use many contacts for lower R
 - Many small contacts for current crowding around periphery



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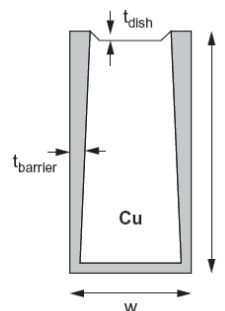
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Copper Issues

- ❑ Copper wires diffusion barrier has high resistance
- ❑ Copper is also prone to *dishing* during polishing
- ❑ Effective resistance is higher

$$R = \frac{\rho}{(t - t_{\text{dish}} - t_{\text{barrier}})} \frac{l}{(w - 2t_{\text{barrier}})}$$



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Example

- ❑ Compute the sheet resistance of a $0.22\text{ }\mu\text{m}$ thick Cu wire in a 65 nm process. Ignore dishing.

$$R_{\square} =$$

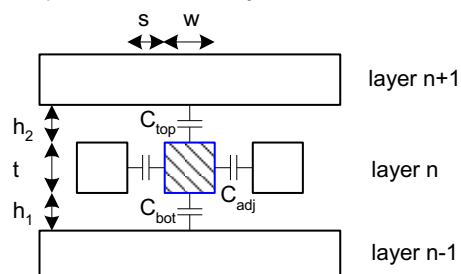
- ❑ Find the total resistance if the wire is $0.125\text{ }\mu\text{m}$ wide and 1 mm long. Ignore the barrier layer.

$$R =$$

Wire Capacitance

- ❑ Wire has capacitance per unit length
 - To neighbors
 - To layers above and below

$$\text{❑ } C_{\text{total}} = C_{\text{top}} + C_{\text{bot}} + 2C_{\text{adj}}$$



Capacitance Trends

- ❑ Parallel plate equation: $C = \epsilon_{ox}A/d$
 - Wires are not parallel plates, but obey trends
 - Increasing area (W, t) increases capacitance
 - Increasing distance (s, h) decreases capacitance
- ❑ Dielectric constant
 - $\epsilon_{ox} = k\epsilon_0$
 - $\epsilon_0 = 8.85 \times 10^{-14} \text{ F/cm}$
 - $k = 3.9$ for SiO_2
- ❑ Processes are starting to use low-k dielectrics
 - $k \approx 3$ (or less) as dielectrics use air pockets

Capacitance Formula

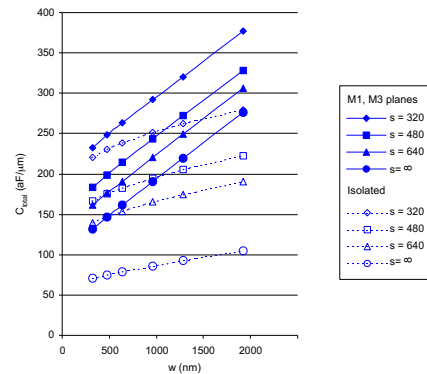
- ❑ Capacitance of a line without neighbors can be approximated as

$$C_{tot} = \epsilon_{ox}l \left[\frac{w}{h} + 0.77 + 1.06 \left(\frac{w}{h} \right)^{0.25} + 1.06 \left(\frac{t}{h} \right)^{0.5} \right]$$

- ❑ This empirical formula is accurate to 6% for $AR < 3.3$

M2 Capacitance Data

- ❑ Typical dense wires have ~ 0.2 fF/ μm
 - Compare to 1-2 fF/ μm for gate capacitance



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Diffusion & Polysilicon

- ❑ Diffusion capacitance is very high (1-2 fF/ μm)
 - Comparable to gate capacitance
 - Diffusion also has high resistance
 - Avoid using diffusion *runners* for wires!
- ❑ Polysilicon has lower C but high R
 - Use for transistor gates
 - Occasionally for very short wires between gates

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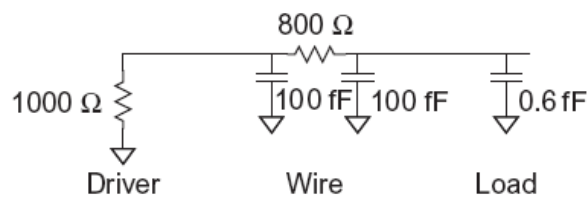
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Wire RC Delay

- Estimate the delay of a 10x inverter driving a 2x inverter at the end of the 1 mm wire. Assume wire capacitance is $0.2 \text{ fF}/\mu\text{m}$ and that a unit-sized inverter has $R = 10 \text{ K}\Omega$ and $C = 0.1 \text{ fF}$.

– $t_{pd} =$



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Wire Energy

- Estimate the energy per unit length to send a bit of information (one rising and one falling transition) in a CMOS process.

□ $E =$

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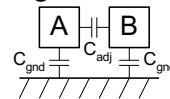
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Crosstalk

- ❑ A capacitor does not like to change its voltage instantaneously.
- ❑ A wire has high capacitance to its neighbor.
 - When the neighbor switches from 1-→ 0 or 0-→1, the wire tends to switch too.
 - Called *capacitive coupling* or *crosstalk*.
- ❑ Crosstalk effects
 - Noise on nonswitching wires
 - Increased delay on switching wires

Crosstalk Delay

- ❑ Assume layers above and below on average are quiet
 - Second terminal of capacitor can be ignored
 - Model as $C_{\text{gnd}} = C_{\text{top}} + C_{\text{bot}}$
- ❑ Effective C_{adj} depends on behavior of neighbors
 - *Miller effect*

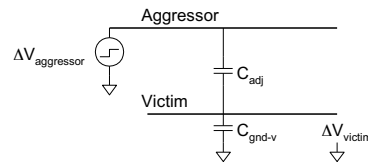


B	ΔV	$C_{\text{eff}}(A)$	MCF
Constant			
Switching with A			
Switching opposite A			

Crosstalk Noise

- ❑ Crosstalk causes noise on nonswitching wires
- ❑ If victim is floating:
 - model as capacitive voltage divider

$$\Delta V_{victim} = \frac{C_{adj}}{C_{gnd-v} + C_{adj}} \Delta V_{aggressor}$$



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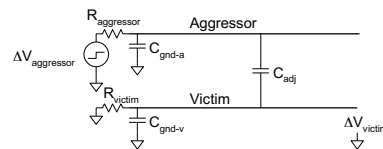
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Driven Victims

- ❑ Usually victim is driven by a gate that fights noise
 - Noise depends on relative resistances
 - Victim driver is in linear region, agg. in saturation
 - If sizes are same, $R_{aggressor} = 2-4 \times R_{victim}$

$$\Delta V_{victim} = \frac{C_{adj}}{C_{gnd-v} + C_{adj}} \frac{1}{1+k} \Delta V_{aggressor}$$

$$k = \frac{\tau_{aggressor}}{\tau_{victim}} = \frac{R_{aggressor} (C_{gnd-a} + C_{adj})}{R_{victim} (C_{gnd-v} + C_{adj})}$$



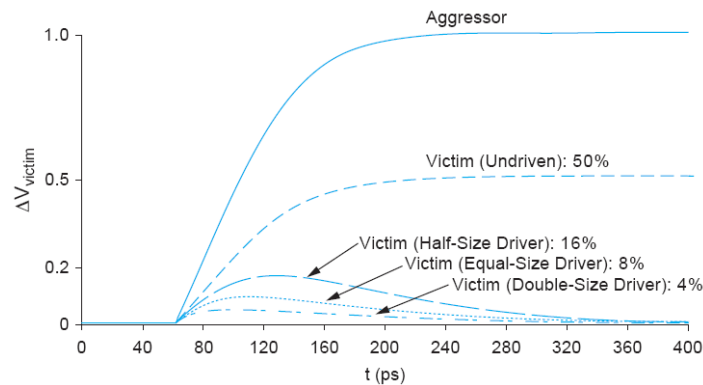
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Coupling Waveforms

- Simulated coupling for $C_{adj} = C_{victim}$



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Noise Implications

- So *what* if we have noise?
- If the noise is less than the noise margin, nothing happens
- Static CMOS logic will eventually settle to correct output even if disturbed by large noise spikes
 - But glitches cause extra delay
 - Also cause extra power from false transitions
- Dynamic logic never recovers from glitches
- Memories and other sensitive circuits also can produce the wrong answer

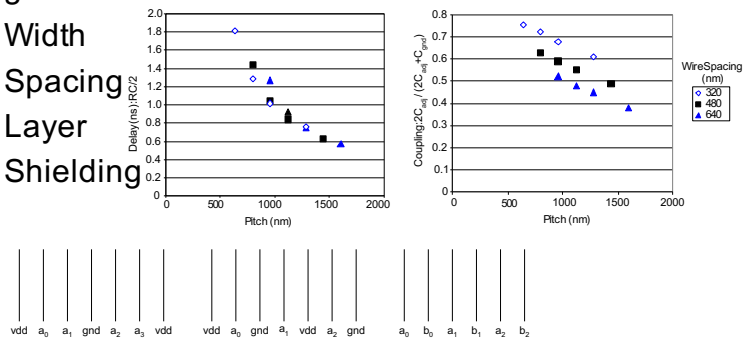
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Wire Engineering

- ❑ Goal: achieve delay, area, power goals with acceptable noise
- ❑ Degrees of freedom:
 - Width
 - Spacing
 - Layer
 - Shielding



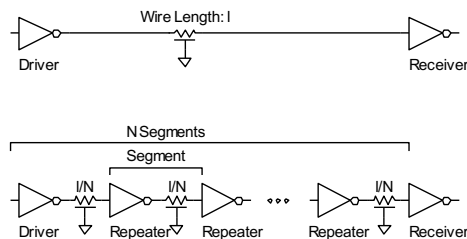
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Repeaters

- ❑ R and C are proportional to
- ❑ RC delay is proportional to
 - Unacceptably great for long wires
- ❑ Break long wires into N shorter segments
 - Drive each one with an inverter or buffer



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Repeater Design

- ☐ How many repeaters should we use?
- ☐ How large should each one be?
- ☐ Equivalent Circuit
 - Wire length l/N
 - Wire Capacitance $C_w * l/N$, Resistance $R_w * l/N$
 - Inverter width W (nMOS = W , pMOS = $2W$)
 - Gate Capacitance $C' * W$, Resistance R/W

Repeater Results

- ☐ Write equation for Elmore Delay
 - Differentiate with respect to W and N
 - Set equal to 0, solve

$$\frac{l}{N} = \sqrt{\frac{2RC'}{R_w C_w}}$$

$$\frac{t_{pd}}{l} = (2 + \sqrt{2}) \sqrt{RC'R_w C_w} \quad \begin{array}{l} \sim 40 \text{ ps/mm} \\ \text{in 65 nm process} \end{array}$$

$$W = \sqrt{\frac{RC_w}{R_w C'}}$$

Repeater Energy

- ❑ Energy / length $\approx 1.87C_wV_{DD}^2$
 - 87% premium over unpeated wires
 - The extra power is consumed in the large repeaters
- ❑ If the repeaters are downsized for minimum EDP:
 - Energy premium is only 30%
 - Delay increases by 14% from min delay